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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chih-Chien Liu, Ta-Shan Tseng, W. B. Shieh, J. Y. Wu,
Water Lur and Shih-Wei Sun

Serial No. 09/991,196

Filed: November 20, 2001

For: HIGH DENSITY PLASMA CHEMICAL VAPOR
DEPOSITION PROCESS

Group Art Unit: 1711

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Confirmation No.: 3908

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